



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA et al.

Group Art Unit: 2851

Application No.: 09/769,832

Examiner: R. E. Fuller

Filed: January 26, 2001

Docket No.: 108455

For: PROJECTION EXPOSURE APPARATUS AND METHOD, CATADIOPTRIC
OPTICAL SYSTEM AND MANUFACTURING METHOD OF DEVICES

#16/C
11/24/03
JF

AMENDMENT FILED WITH RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

After entry of the Request for Continued Examination (RCE) filed herewith, please
consider the following:

Amendments to the Claims as reflected in the listing of claims;

Remarks.